

Practitioner's Docket No. MI22-1098

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Schuegraf, Klaus F.

Application No.: 09/212,726

Group No.: 2813

Filed: 12/15/1998

Examiner: Erik Kielin

For: Semiconductor Processing Methods of Chemical Vapor Depositing SiO₂ on a Substrate**Assistant Commissioner for Patents**
Washington, D.C. 20231

REQUEST FOR CORRECTED FILING RECEIPT

1. Attached is a copy of the official filing receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.

2. There is an error with respect to the following, which is incorrectly entered.

CERTIFICATE OF MAILING/TRANSMISSION (37 C.F.R. section 1.8a)

I hereby certify that this correspondence is, on the date shown below, being:

MAILING deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.**FACSIMILE** transmitted by facsimile to the Patent and Trademark Office to 703-308-7751 6 pagesJaime M. White
SignatureDate: 3/7/2002Jaime M. White fax no. 509-838-3424
(type or print name of person certifying)

*Error in**Correct data*

1. CPA filed on: 11/30/2001

1. CPA filed on: 01/30/2001

3. The correction is not due to any error by applicant and no fee is due.

Date: 3-7-2002Jennifer J Taylor

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UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/212,726	12/15/1998	2813	838	M122-1098	2	10	4

21567
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CONFIRMATION NO. 7984

CORRECTED FILING RECEIPT



"OC000000008031238"

Date Mailed: 05/02/2001

Receipt is acknowledged of a CPA in this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

KLAUS F. SCHUEGRAF, BOISE, ID;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted 01/29/1999

CPA filed on: 11/30/2001

Projected Publication Date: 08/09/2001

Non-Publication Request: No

Early Publication Request: No

Title

SEMICONDUCTOR PROCESSING METHODS OF CHEMICAL VAPOR DEPOSITING SiO2
ON A SUBSTRATE

#16
3/12/02
MHL

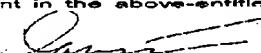
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.	09/212,726
Filing Date	December 16, 1998
Inventor	Klaus F. Schuederle
Assignee	Micron Technology, Inc.
Group Art Unit	2813
Examiner	Erik Kellin
Attorney's Docket No.	MI22-1098
Title: Semiconductor Processing Methods of Chemical Vapor Depositing SiO ₂ on a Substrate	

Assistant Commissioner of Patents
Washington, D.C. 20231

ASSOCIATE POWER OF ATTORNEY

Please recognize Jennifer J. Taylor, Ph.D. (Reg. No. 48,711) whose post office address is 601 W. First Avenue, Suite 1300, Spokane, Washington 99201-3828, as an associate attorney or agent in the above-entitled application.

Date: 3/7/02

 David G. Latwesen, Ph.D.
 Reg. No. 38,533

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